

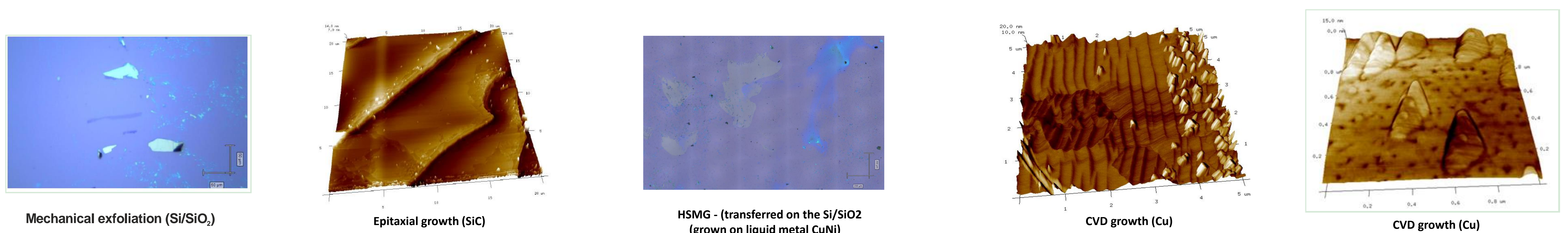
CHARACTERIZATION OF THE BARRIER AND ELECTROCHEMICAL PROPERTIES OF CVD GRAPHENE ON METALLIC SUBSTRATES

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Introduction

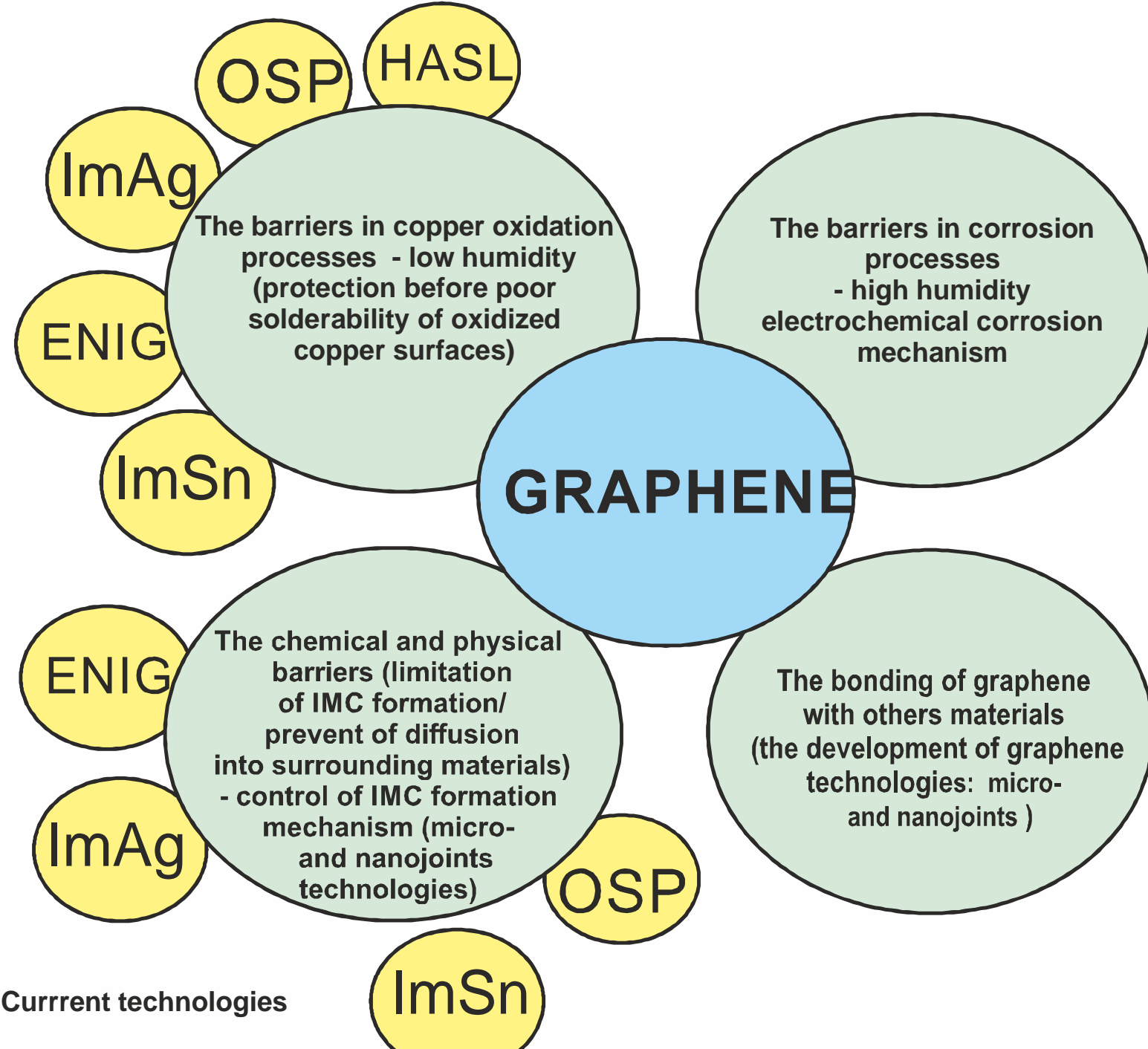
Growth of graphene using the CVD method (so-called CVD graphene) on mono- and polycrystalline copper surfaces give the possibility to obtain large-area graphene coatings [1]. The CVD graphene can be also transferred onto other metallic or non-metallic substrates. The results of many investigations indicate that graphene can provide a barrier substantially reduce the corrosion rate (e.g.[2,3]), however, the tightness of real graphene coating is a fundamental feature of barrier protection [1-4]. The experimental investigations of barrier properties of graphene layers included the development of methodical bases for characterization of obtained layers (optical microscopy,  $\mu$ -Raman Spectroscopy and AFM).

Different techniques to obtain graphene films (examples)

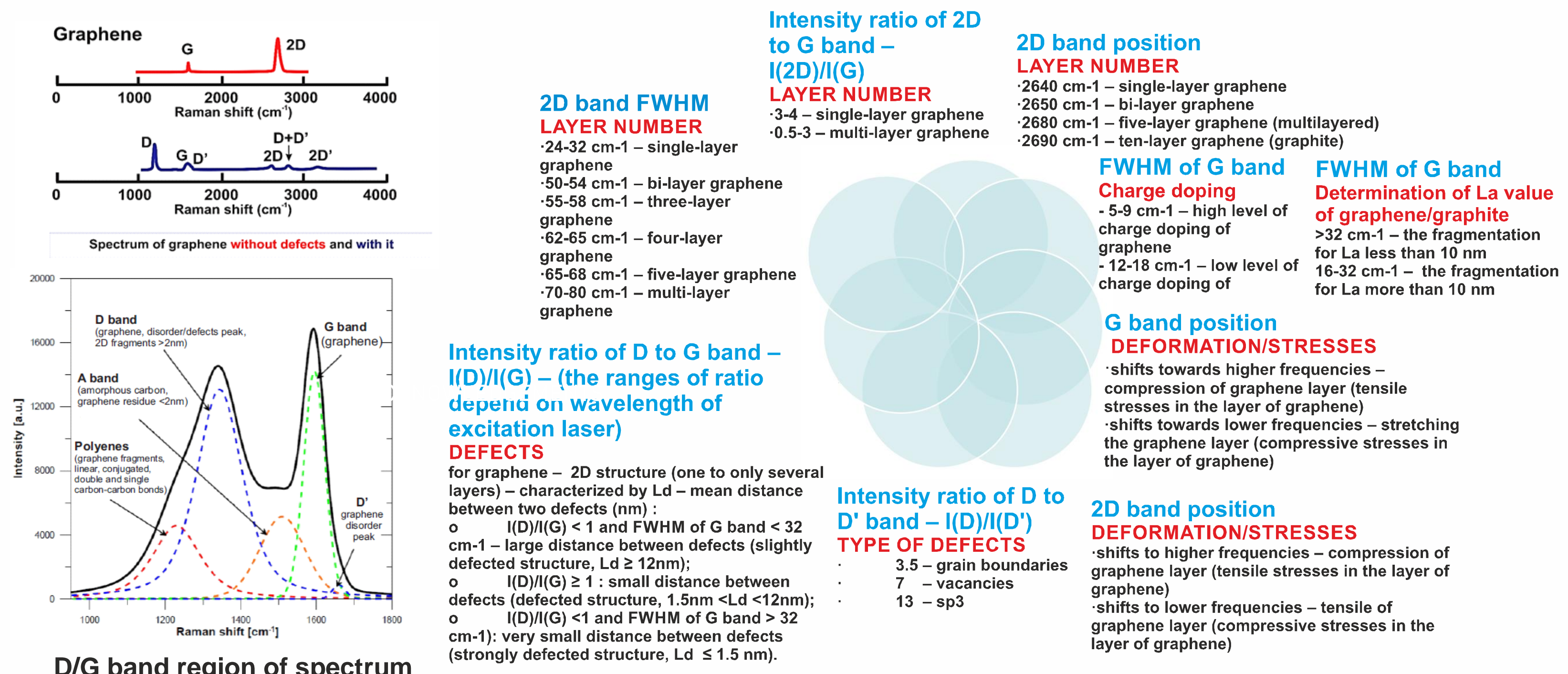


The barrier properties of CVD graphene

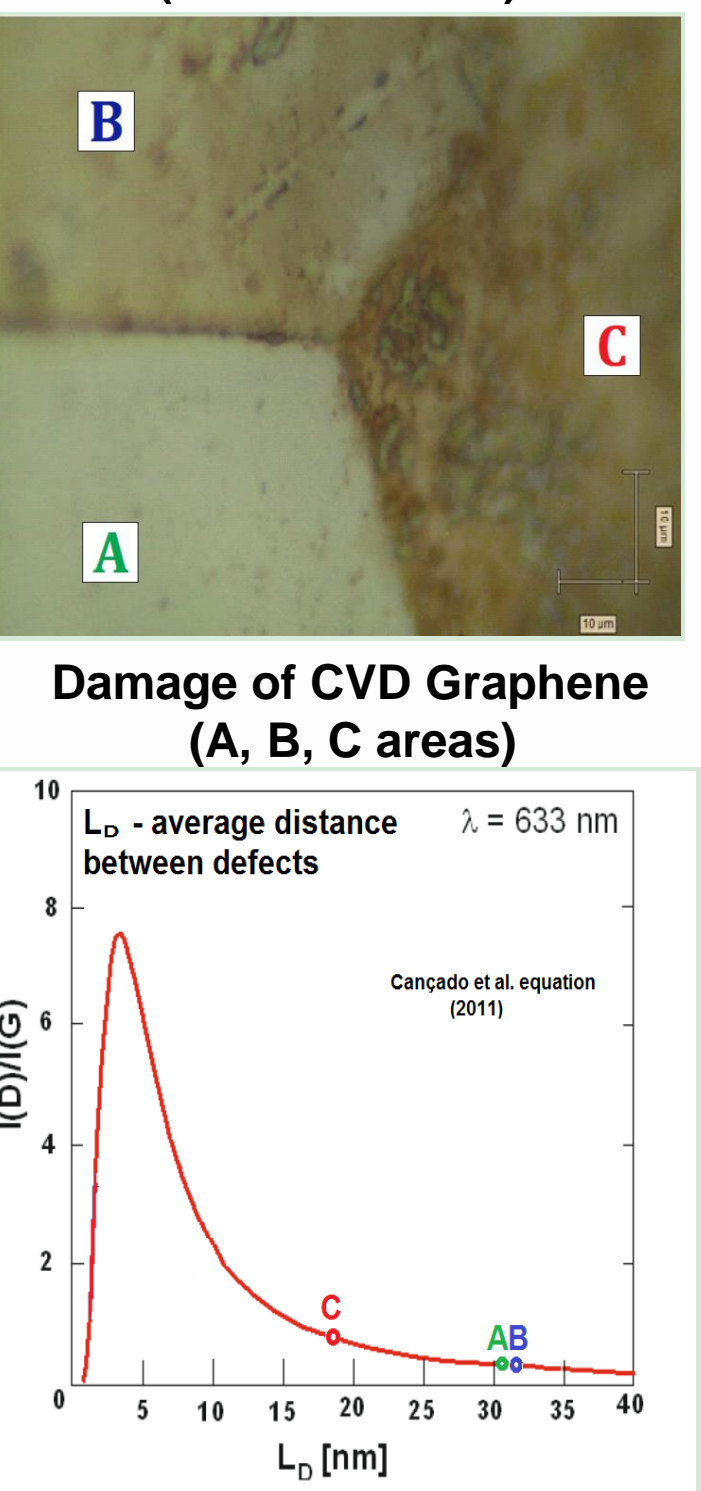
The barrier properties of graphene  
Selected applications



The characterization of barrier properties of graphene  
Raman Spectroscopy

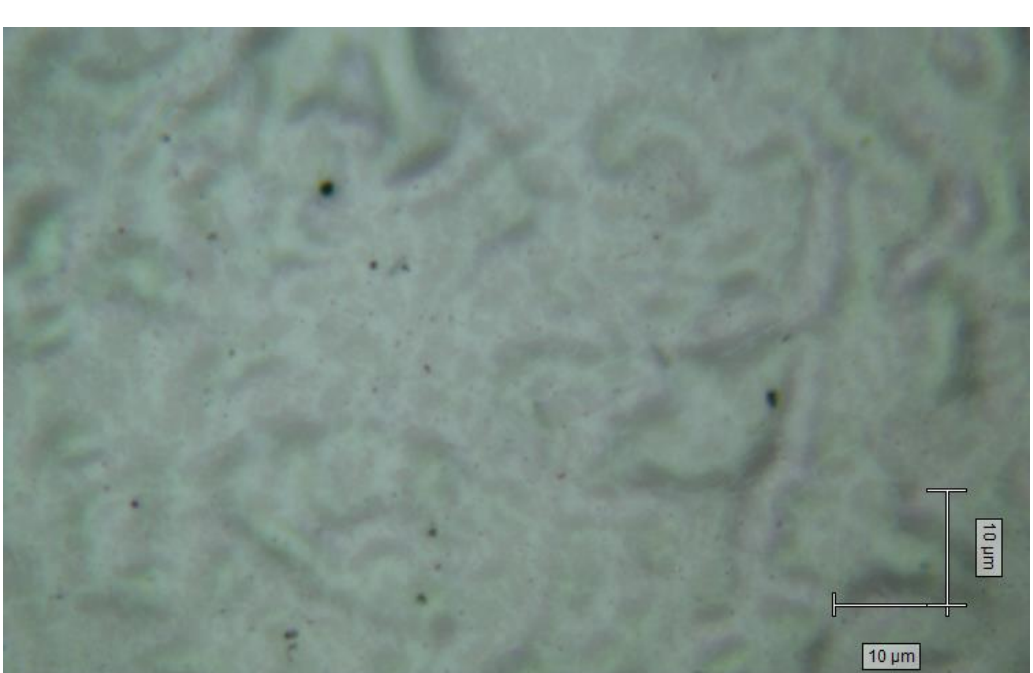


Oxidation of copper under CVD Graphene (after 9 months)

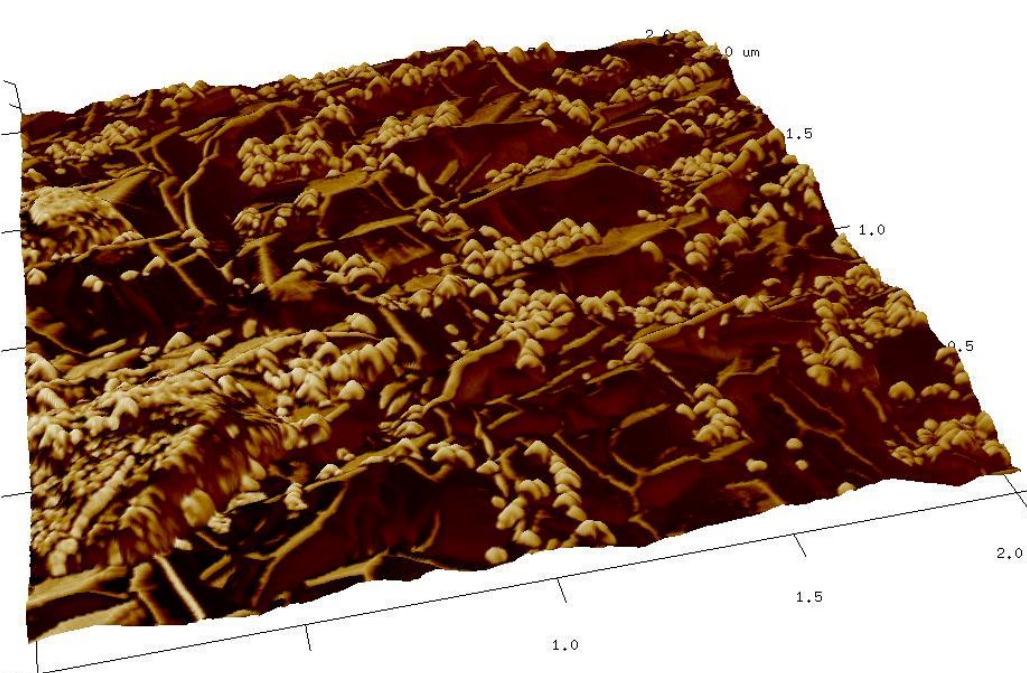


The electrochemical properties of CVD graphene

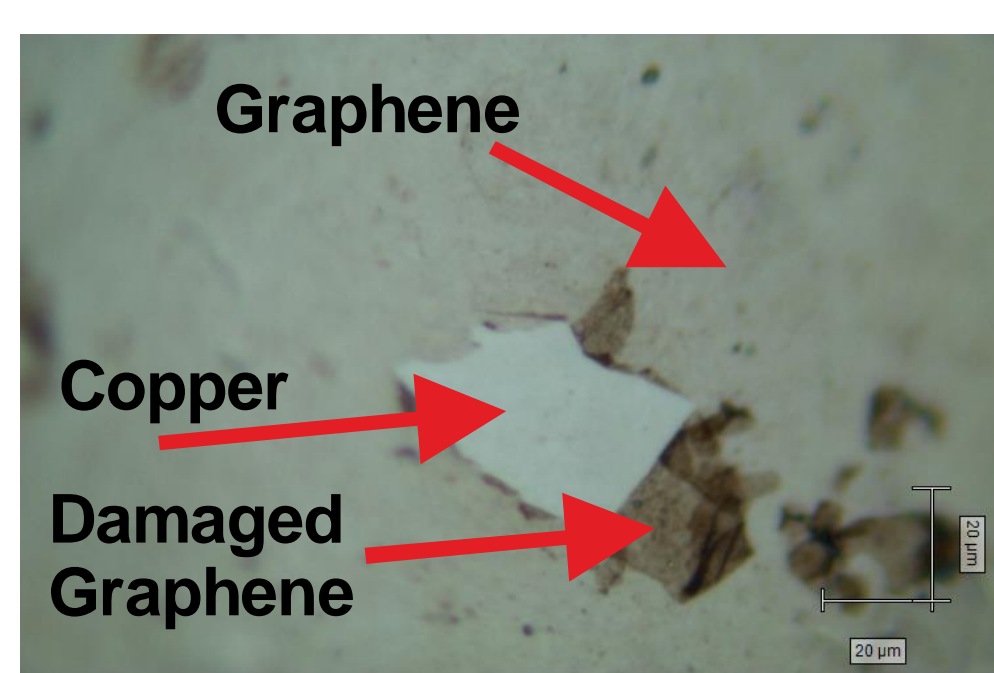
CVD Graphene on the copper substrate (optical microscopy)



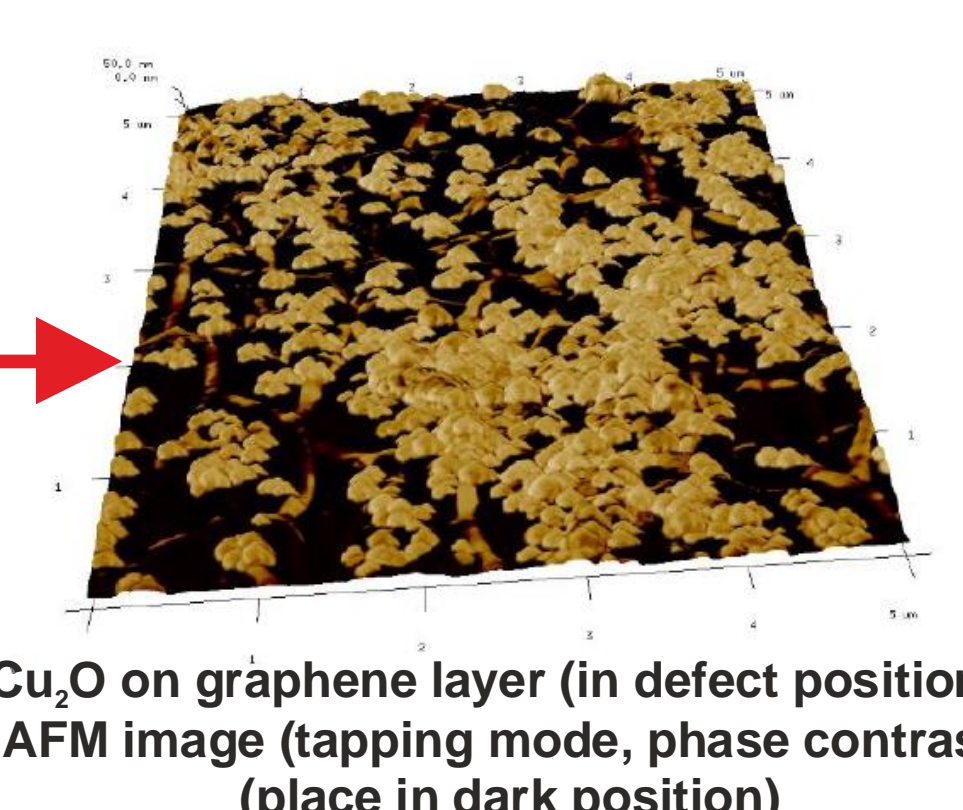
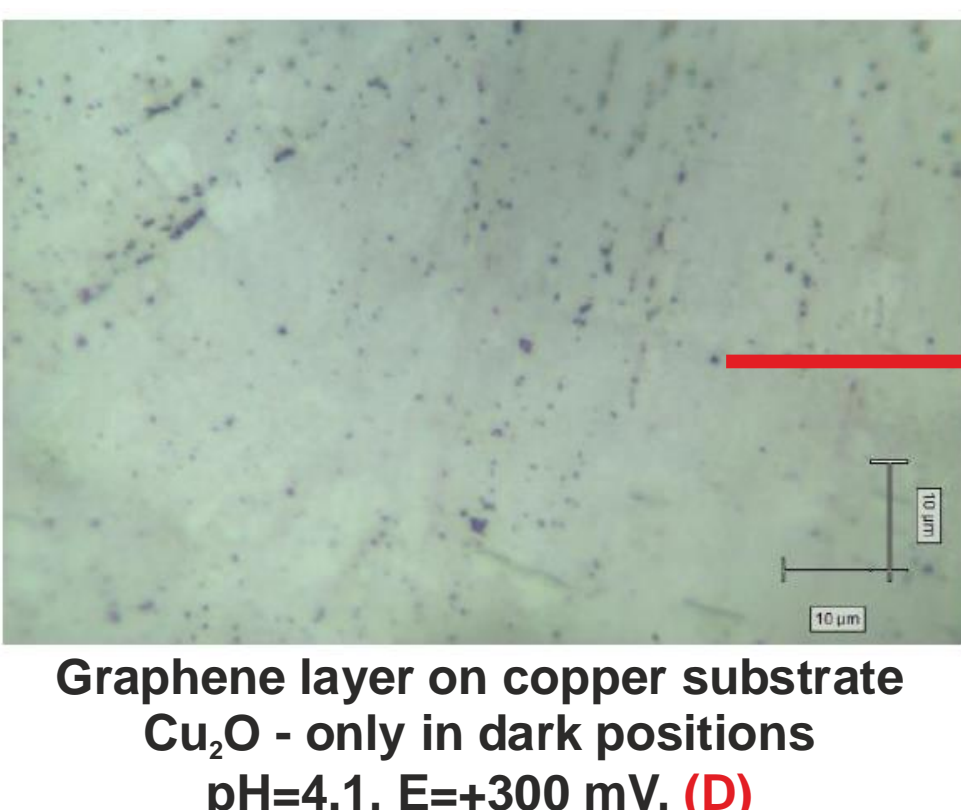
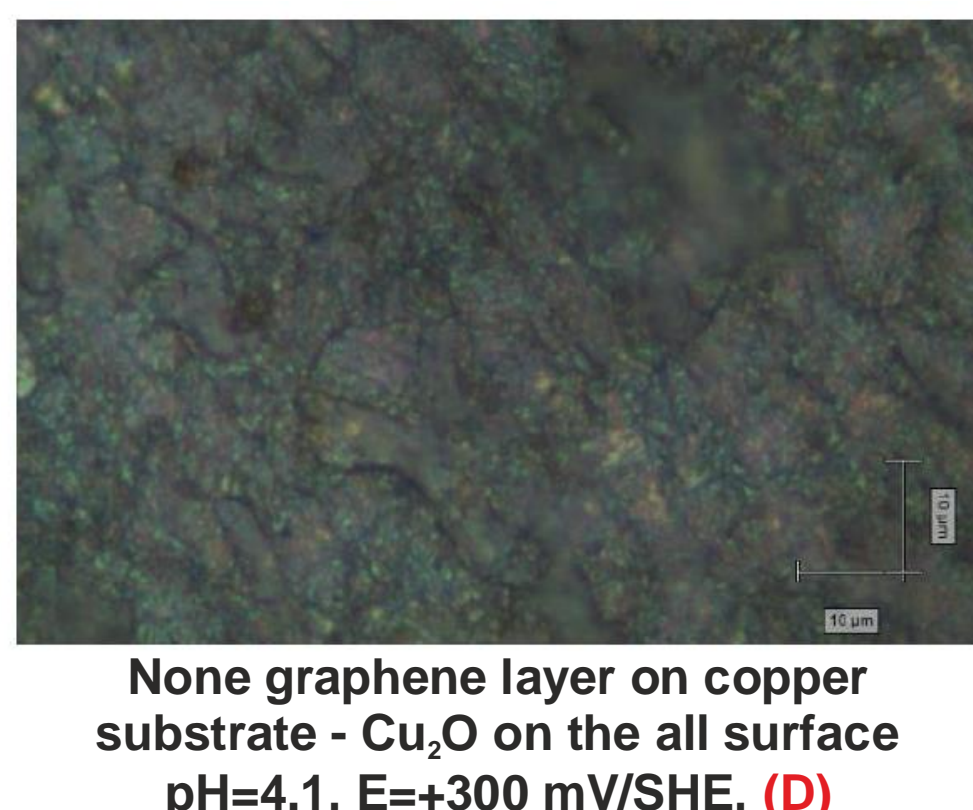
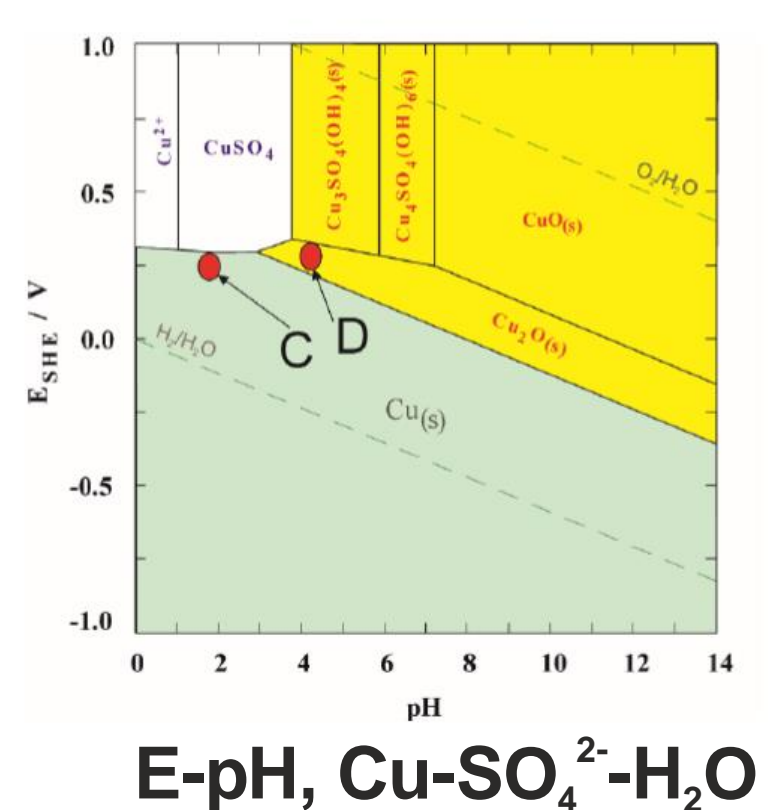
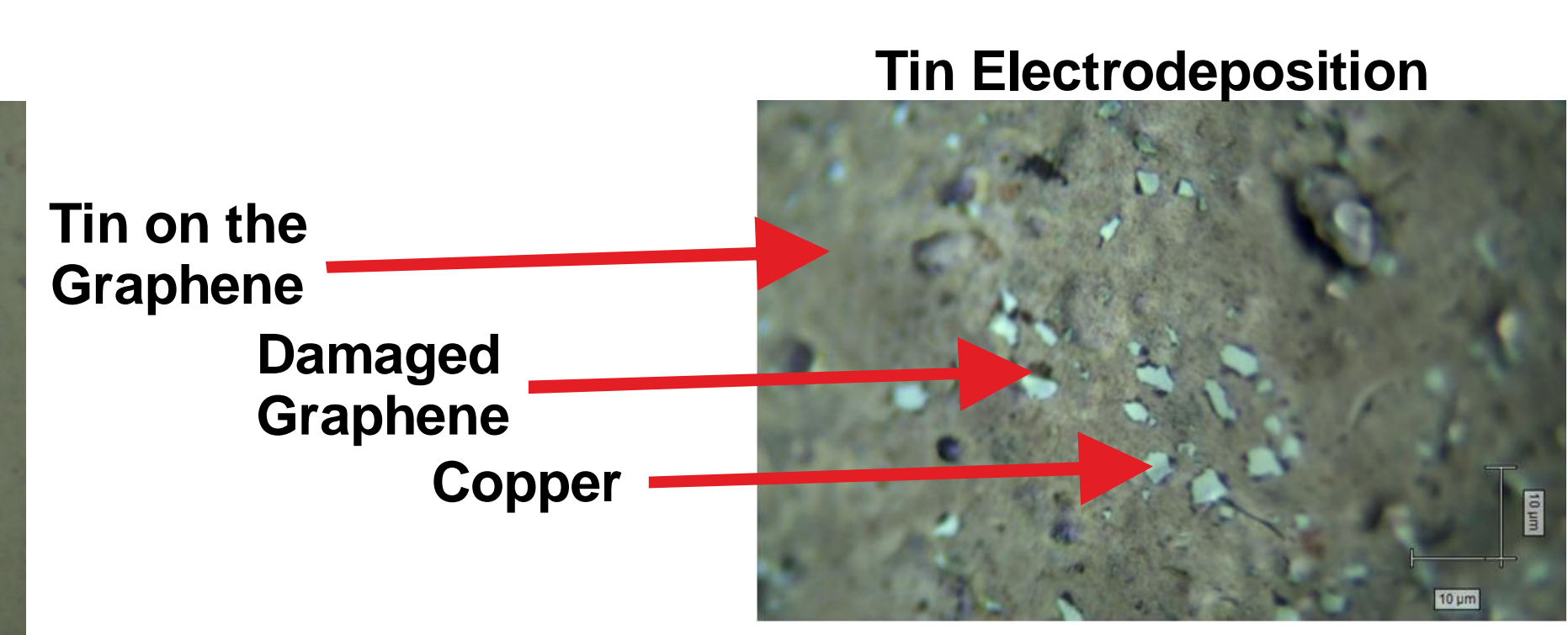
CVD Graphene on the copper substrate (AFM)



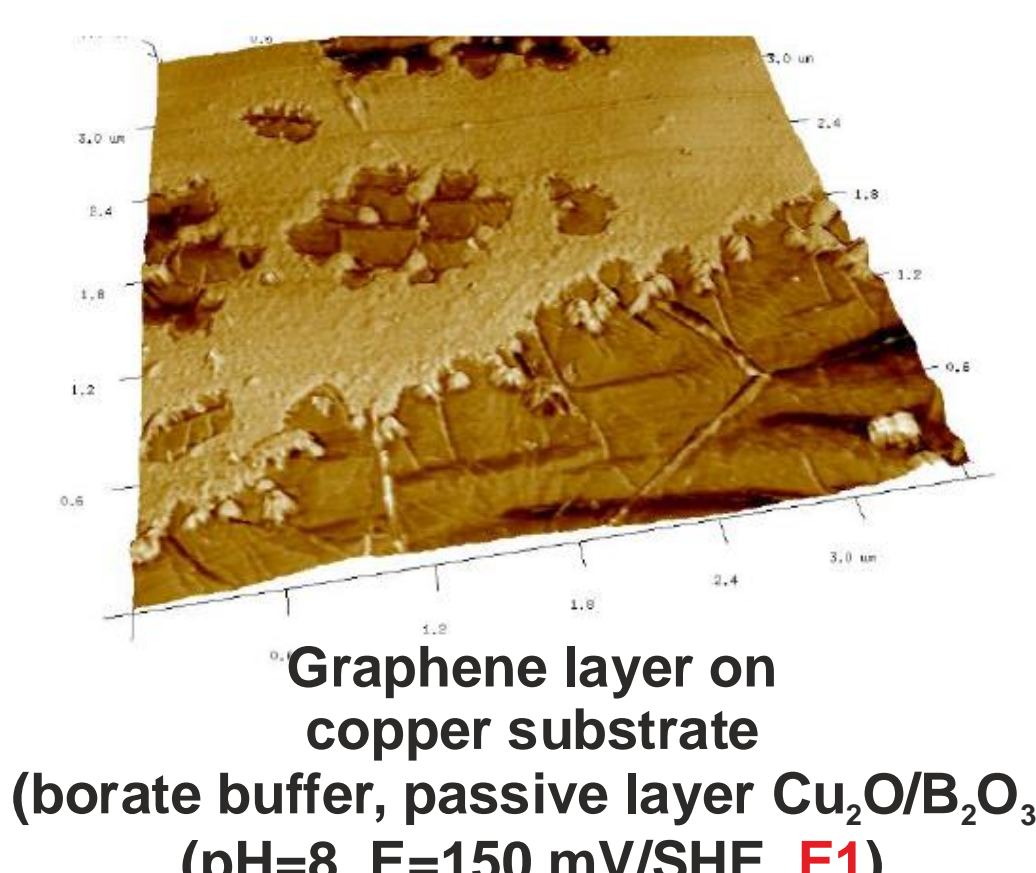
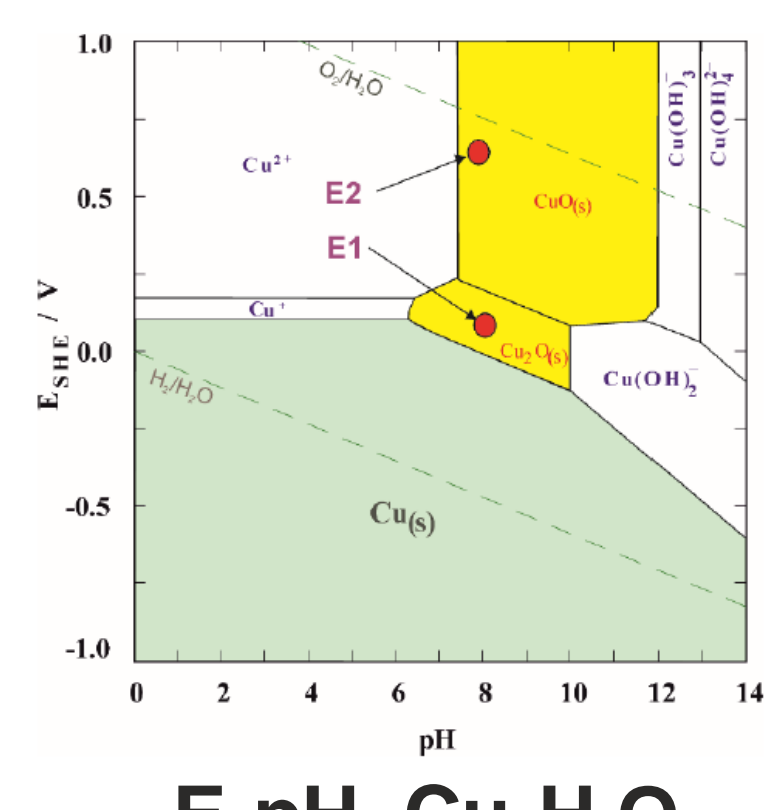
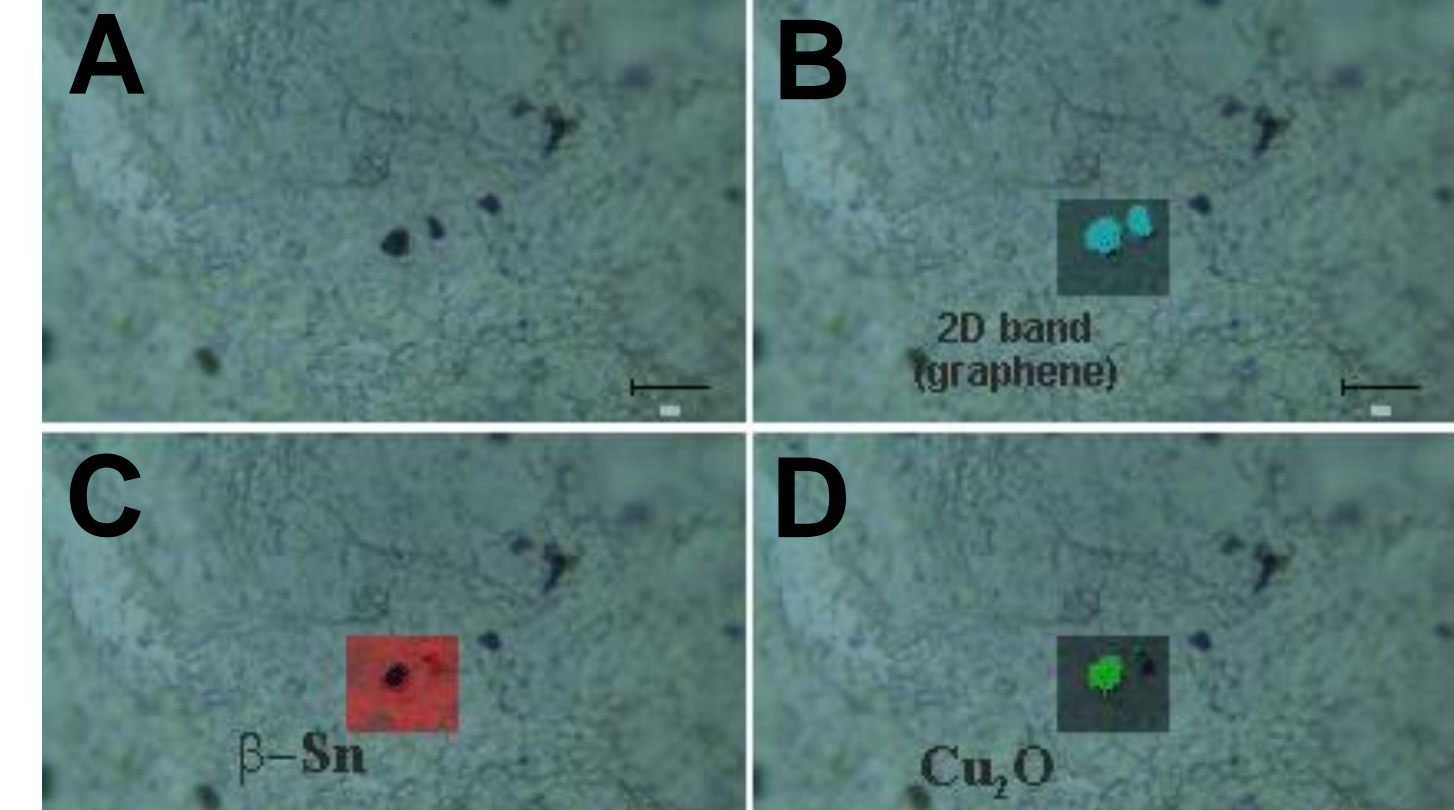
Hydrogen evolution on the CVD Graphene (damaged of Graphene film)



Selective electrodeposition of metals on CVD Graphene/Cu after hydrogen evolution



Electrodeposited tin layer (substrate: CVD graphene on the copper):  
A) Optical image - black places in tin layer;  
B) Raman map of 2D band of Graphene (2840 cm<sup>-1</sup>) - blue;  
C) Raman map of beta-Sn band (127 cm<sup>-1</sup>) - red;  
D) Raman map of Cu<sub>2</sub>O band (450-680 cm<sup>-1</sup>) - green.  
(black places: defective Cu<sub>2</sub>O-graphene places on the copper/graphene substrate)



Conclusions:

- The obtained results indicate a strong influence of defects in CVD graphene materials (types, density), an important role of substrate preparation (topography, roughness, oxidation) and corrosion products as well as an influence of electrodeposition conditions on the barrier properties of graphene layers.
- The damages of graphene coatings by copper substrate and improper electrodeposition conditions can be analysed by  $\mu$ -Raman Spectroscopy ( $\mu$ -RS), Atomic Force Microscopy (AFM) and Optical Microscopy (OM).

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REFERENCES

- S. Maarof, A.A. Ali, A.M. Hashim, Nanoscale Research Letters, 14 (2019) 143.
- N.T. Kirkland, T. Schiller, N. Medhekar, N. Birbilis, Corrosion Science, 56 (2012) 1.
- K.S. Aneja, S. Bohm, A.S. Khanna, H.L.M. Bohm, Nanoscale, 42 (2015) 17879.
- S.P. Damari, L. Cullari, D. Laredo, R. Nadiv, E. Ruse, R. Sripada, O. Regev, Progress in Organic Coatings, 136 (2019) 105207.